



AF 3700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David M. Curran, et al.

Serial No: 10/029,788

Examiner: Timothy V. Eley

Filed: 10/26/2001

For: METHOD FOR REDUCING THE THICKNESS OF SPIN-ON GLASS ON
SEMICONDUCTOR WAFERS

Docket No: TI-29038

Conf. No: 5683

Art Unit: 3724

#6 (N.E.)

2/13/04

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AMENDMENT PURSUANT TO 37 CFR 1.116

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I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 1-29-04.

Ann Trent
Ann Trent

*OK to Enter
02/20/04 On Appeal*

Dear Sir:

Responsive to the Office Action mailed December 31, 2003, in connection with the above identified application, Applicants respectfully submit the following remarks.

Amendments to the Specification:

None